



Docket No.: 8733.307.00-US  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Oh-Nam Kwon

Confirmation: 4557

Application No.: 09/709,483

Art Unit: 2823

Filed: November 13, 2000

Examiner: T. V. Pham

For: METHOD OF MANUFACTURING A THIN  
FILM TRANSISTOR

Customer: 30827

**RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Final Office Action dated February 4, 2005 (Paper No. 20050125), please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Amendments to the Drawings** begin on page 5 of this paper and include an attached annotated sheet showing changes.

**Remarks/Arguments** begin on page 6 of this paper.

An **Appendix** including amended drawing figures is attached following page 12 of this paper.

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